Instrument Systems
KONICA MINOLTA Group

Testing Solutions for VCSELs

With High Resolution Array Spectroradiometer

The unique properties of vertical-cavity surface-emitting lasers (VCSELs) make them a workhorse for price-sensitive laser-based applications, e.g. in consumer electronics. In production, this demands mass-market-suitable, fast and highly reliable quality control of VCSELs. Instrument Systems provides test solutions for the comprehensive characterization and inspection of the temporal, electrical, spectral and spatial properties of such laser diodes in production as well as in the laboratory. For fast and reliable testing we offer a high-resolution array spectroradiometer (CAS). Together with an integrating sphere and an absolutely referenced photodiode it provides a highly precise and accurate measurement system for production. Furthermore, the new VTC system allows for the analysis of a VCSEL array on single emitter level, e.g. to determine the radiant power and wavelength. The emission profile of the overall array from a larger distance can be determined by measuring with a light-permeable screen or a goniophotometer setup.

APPLICATION
NOTE

\\ 1. INTRODUCTION

Most of the research activities in vertical-cavity surface-emitting lasers (VCSELs), a special kind of semiconductor laser diode, started already as early as 1979. Since that time, VCSELs have become a mature technology, competing in many applications with edge-emitting laser diodes (EEL) and even replacing them in certain applications like short-range fiber optical communication. The emission of light, perpendicular to the epitaxial layers makes them very suitable for mass production as it enables optical testing and binning on the wafer level. Additionally, precise manufacturing process control made it possible to reduce the price for VCSELs below EELs. The lower price together with favorable properties like a symmetric beam profile, low power consumption and high modulation bandwidth lead to their wide spread use in applications as diverse as laser printers, optical mouses or optical data communication. In recent times, VCSELs and especially 2D VCSEL arrays appear also as an enabling technology for a wide range of emerging applications and markets in 3D sensing, such as

» Face & gesture recognition
» Autonomous driving
» Novel human-machine interfaces

Instrument Systems provides customizable solutions (hardware & software) for the characterization and quality control of the electro-optical properties of VCSELs in the lab as well as in production environments.



Fig. 1: Short-range LiDAR systems are investigated as a potential application for VCSELs.

\\ 2. VCSEL TESTING IN PRODUCTION LINES

Quality control of VCSELs and EELs in production lines requires the full optical characterization of a device-under-test (DUT) within milliseconds. For this, the combination of an integrating sphere (ISP) and a high-resolution array spectroradiometer (CAS) is the ideal system for fast and reliable tests of semiconductor laser diodes (Fig. 2), determining key characteristics like the centroid wavelength and the radiant power (Fig. 3). The high measurement speed requires that such spectral measurements are usually carried out with only a single, millisecond long optical pulse in the integration time window of the spectroradiometer.

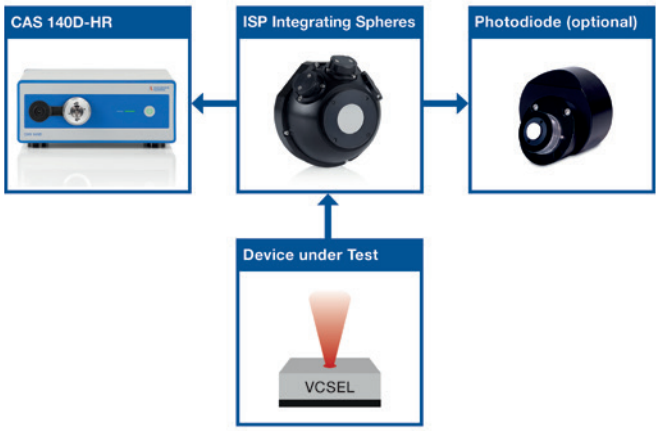


Fig. 2: High-resolution array spectroradiometers with integrating spheres allow for the fast and reliable spectral characterization of VCSELs. Optional photodiode sensors can further increase the precision of the radiant power measurement.

In such systems, the integrating sphere homogenizes the light field and the array spectroradiometer has to record the laser spectrum with the necessary accuracy and measurement speed. For light sources with a very narrow spectrum, the precision of the radiant power measurement can be further increased with an additional photodiode sensor attached to and calibrated with the ISP. It is recommended for high precision measurements to correct for deviations due to the wavelength-dependent reflectivity of the DUT and its surroundings with the self-absorption correction method. For this, it is necessary

to choose an appropriate auxiliary light source with a suitable spectral power density distribution. The narrow spectral bandwidth of VCSELs – typically in the range of a nanometer – requires spectroradiometers with sub-nanometer spectral resolution. Instrument Systems offers with the CAS 140D-HR, the CAS 120(B)-HR and CAS125-HR three production grade high-resolution spectrometer platforms and additionally integrating spheres and suitable auxiliary light sources for semiconductor laser diode testing. This allows to provide customers a broad bandwidth of measurement solutions:

Key features

- High spectral resolution down to 0.09 nm
- PTB traceable measurements
- High sensitivity for high throughout (UPH)
- Short integration times down to 4 ms with CAS 140D-HR & CAS 120(B)-HR, 10 µs with CAS 125-HR
- Optional: ISP with PD 100 photodiode
- Optional: auxiliary light source for DUT specific self-absorption correction

Key results

- Optical spectrum
- Peak wavelength
- FWHM
- Radiant power

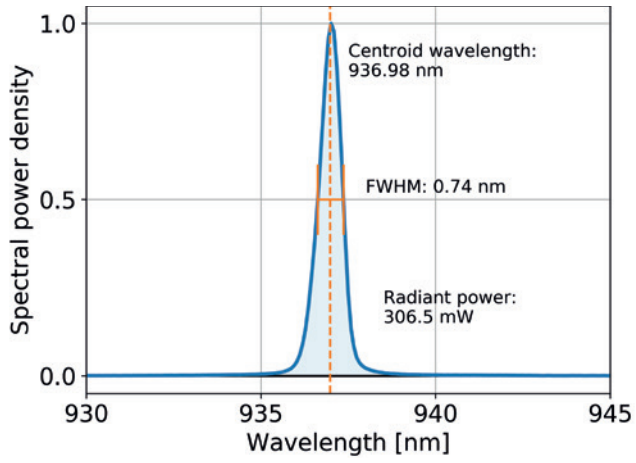


Fig. 3: Example spectrum of a 2D VCSEL array measured with a CAS 140CT-HR.

\\ 3. SPATIALLY RESOLVED SINGLE EMITTER MEASUREMENTS

Identifying the functionality and quality of a VCSEL array on single emitter level is an important task in production environments and can be carried out by the VTC system (VCSEL Testing Camera, see Fig. 4).

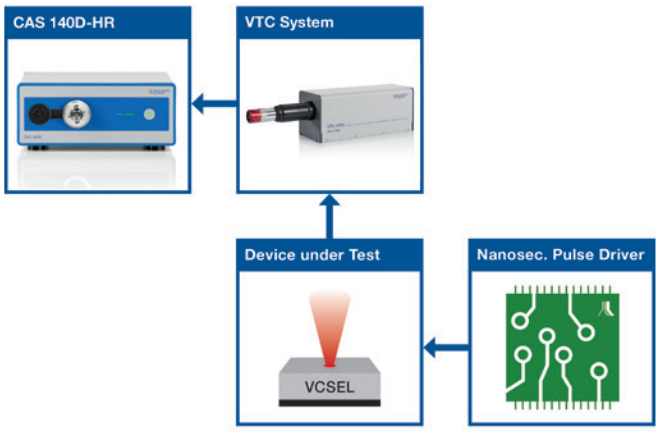


Fig. 4: The VTC system consists of the camera with microscope optics and a port for connecting a CAS spectrometer. Optionally, the Pulse Driver can be used for driving the DUT.

This specially designed system consists of a camera and microscope optics and permits measuring the spatial distribution of the light from a VCSEL array with a single shot image. The information enables the analysis of each single emitter in terms of absolute power within a very short time-frame, enabling e.g. defect detection even in production. The system is optionally equipped with a translation stage moving only the optical parts without the need of repositioning the DUT during the measurement. It allows stitching for large DUTs and precise positioning with an uncertainty smaller than 2 µm. An additional CAS-HR spectrometer enables an analysis of the spectrum for each single emitter on the array. Fig. 5 shows a typical image of such a measurement.

The camera system is flat-field corrected and comes with an absolute calibration traceable to national standards. The optical resolution is around 2.2 µm and the Field-of-View is 1 mm x 1 mm.

The VTC allows to measure a series of images of the VCSEL array in order to get all optical parameters of the array: position in x and y, focus position, absolute power, numerical aperture, waist and M^2 value. Together with a CAS spectroradiometer, the spectrum of each individual emitter can be characterized including peak and centroid wavelength (see figure 11 for an example).

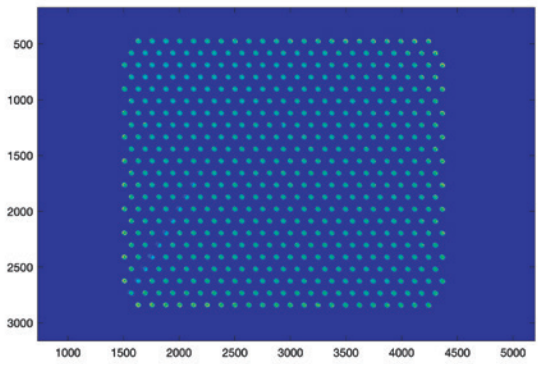


Fig. 5: 2D image of sample VCSEL, imaged with VTC system.

Key features

- Single shot solution for evaluating spatial distribution of a VCSEL
- 1 mm x 1mm Field-of-View, stitching possible
- 0.35 µm pixel size
- Translation stage optional, no movement of DUT needed
- Traceable absolute calibration
- Fully compatible with LumiSuite software

Key results per emitter

- Absolute power
- Numerical aperture
- Peak wavelength
- Waist

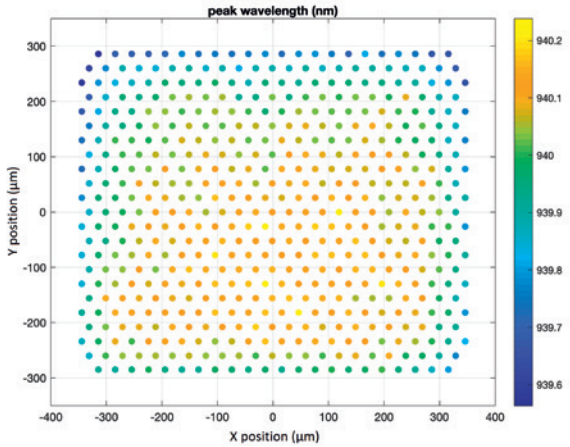


Fig. 6: Measured peak wavelength of a sample VCSEL using a CAS-HR and VTC system.

\\ 4. ANGULAR-RESOLVED MEASUREMENT IN FAR-FIELD

4.1 VCSEL far-field system

Characterizing the angular-resolved emission of the VCSEL array in the far field is another highly relevant application. On the one hand, far-field measurements give information on the divergence of the emitted beam, which is an important parameter in many VCSEL applications. On the other hand, identifying the emitted intensity profile from a distance is crucial for eye safety reasons and needs exact examinations. Instrument Systems offers different solutions for characterizing this emission profile, e.g. the VCSEL Far-Field System (based on a light-permeable screen) for price-sensitive applications and various goniophotometer solutions for highest accuracy and flexibility.

The cost-efficient far field system shown in Fig. 7 uses a light-permeable screen to measure the intensity distribution of the emitted light. Fig. 7 shows the sketch of the setup: The DUT irradiates the screen and the transmission of the screen is imaged by a camera system. This setup allows to measure the angular distribution of the emission of the VCSEL array. The camera exhibits a radiometric calibration traceable to the PTB.

Key features

- Cost-effective solution for measuring angular distribution of a VCSEL array
- For one-shot solution
- Traceable, absolute calibrated

Key results

- Absolute radiometric measurement
- Angular distribution of the VCSEL
- Opening angle and numerical aperture
- Emission profile, e.g. intensity peaks and valleys
- Height of intensity peaks as well as distance between them

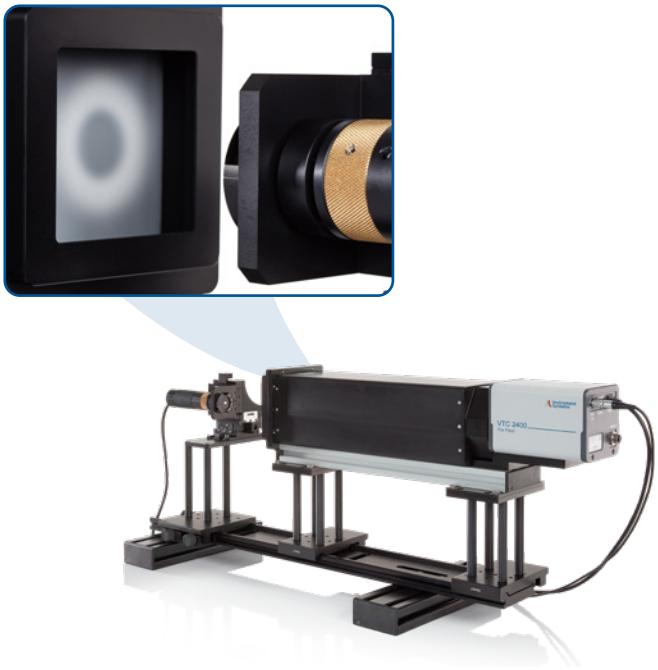


Fig. 7: The DUT irradiates the screen which is imaged by a camera system.

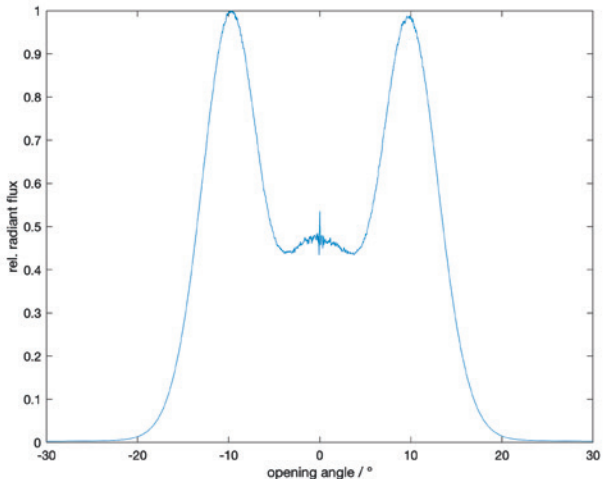


Fig. 8: The angular distribution of a sample VCSEL measured with the transmission screen.

4.2 Goniophotometer

In order to characterize the angular-dependency of the light emitted by the VCSEL in even more detail, goniophotometer measurements can be carried out, e.g. with Instrument System's LEDGON or LGS series. With these systems, the spatial emission pattern can be analyzed over the complete forward hemisphere with a very high angular accuracy of 0.1° for the LEDGON and 0.01° for the LGS 350 system. This is especially important for narrow emission devices such as VCSELs.

Fig. 9 shows a typical 3D emission profile of a VCSEL device measured in a goniometer setup . Clearly visible is the characteristic donut-like profile of the emission pattern, which can be analyzed both in 2D and in 3D. The goniophotometer solutions of Instrument Systems offer the possibility to characterize the emission pattern of a single emitter as well as for a complete VCSEL ensemble. Furthermore, analysis can be executed in both continuous wave or pulsed operation mode.

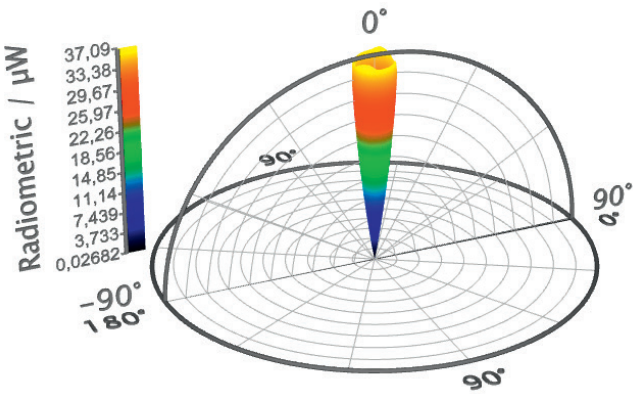


Fig. 9: 3D emission pattern of a sample VCSEL.

\\ 5. OUTLOOK: FAST AND HIGHLY PRECISE VCSEL TESTING FOR PRODUCTION

Increasing demands on quality control and compliance (especially eye and skin safety) require reliable as well as extremely fast and precise VCSEL testing solutions. Relevant quantities such as absolute power, wavelength, single emitter defects, numerical aperture, and beam uniformity have to be measured with a very high accuracy to avoid safety issues. Instrument Systems provides a comprehensive, yet modular solution adapted to your individual needs. In the future many applications make it necessary to transfer laboratory-proven tests for VCSELs to production lines. Especially for security-relevant components like LiDAR systems (in the field of autonomous driving) or in consumer electronics, manufacturers will have to ensure that each VCSEL responds correctly to the driving signals in the final device. This requires not only testing the complete VCSEL array but also each single emitter. Temporally and spatially resolved optical testing with predefined driving pulse patterns in production can make this feasible. Here, the development of production grade contacting for driving the DUTs with high-frequency nanosecond pulses, which have bandwidths in the gigahertz range, is considered to be one of the major challenges. Also, ever-increasing array sizes and/or NA values pose high demands on the measurement devices. Instrument Systems is working on transferring our measurement solutions from well-proven laboratory systems to VCSEL tests in production and can support customers in this field with our longstanding optical metrology experience in mass production of light-emitting semiconductors.

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